

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Paten	t App	lication	on of
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Nathan S. Lewis et al.

Application No.: 09/905,157

Filed: July 12, 2001

For:

ELECTRICAL PASSIVATION OF

SILICON-CONTAINING SURFACES

USING ORGANIC LAYERS

Mail Stop AF

Group Art Unit: 2813

Examiner: Heather Anne Doty

Confirmation No.: 2732

Certificate of Mailing
I hereby certify that this correspondence is being deposited with the United States Postal Service as First Class Mail in an envelope addressed to Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450

on September 10, 2007.

Kim A. Cabello

not enter 2007

RESPONSE

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

The following remarks are in response to the Final Office Action mailed May 8, 2007. This response is being filed with a one-month extension of time and thus is being timely filed on September 10, 2007 (September 8, 2007, is a Saturday). Applicants respectfully request entry of the following remarks: